

AMENDMENT TRANSMITTAL LETTER (Large Entity)

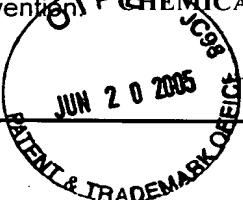
Applicant(s): Ju-Cheol SHIN et al.

Docket No.

SEC.828D

Application No. 10/601,561	Filing Date June 24, 2003	Examiner Karla A. Moore	Customer No. 20987	Group Art Unit 1763	Confirmation No. 7739
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Invention P CHEMICAL VAPOR DEPOSITION APPARATUS FOR DEPOSITING SILICIDE

COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	7 -	20 =	0	x \$50.00	\$0.00
INDEP. CLAIMS	1 -	3 =	0	x \$200.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

No additional fee is required for amendment.

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- Any additional filing fees required under 37 C.F.R. 1.16.
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Dated: JUNE 20, 2005

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Application No. 10/601,561
Attorney Docket No. SEC.828D

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of :
Ju-Cheol Shin et al. : Group Art Unit: 1763
Application No. 10/601,561 : Examiner Karla A. Moore
Filed: June 24, 2003 :

Title: CHEMICAL VAPOR DEPOSITION APPARATUS FOR DEPOSITING SILICIDE

AMENDMENT AFTER FINAL

U.S. Patent and Trademark Office
Customer Service Window, Mail Stop AF
Randolph Building
401 Dulany Street
Alexandria VA 22314

Sir or Madam:

In response to the Office Action of May 9, 2005, please amend the application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.